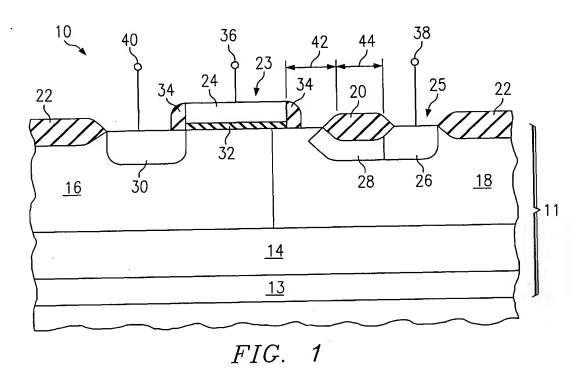
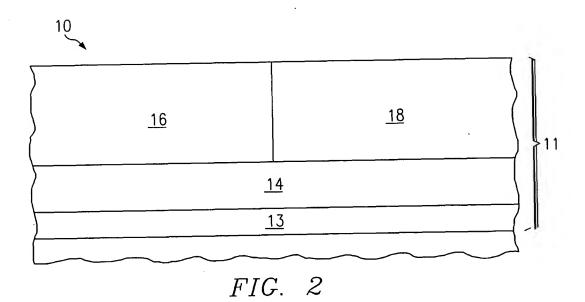
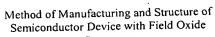
Method of Manufacturing and Structure of Semiconductor Device with Field Oxide Structure Attorney Docket: 032350.B373 Inventor: Xiaoju (nmi) Wu Filed: 12/07/2001 Sheets: 1 of 3

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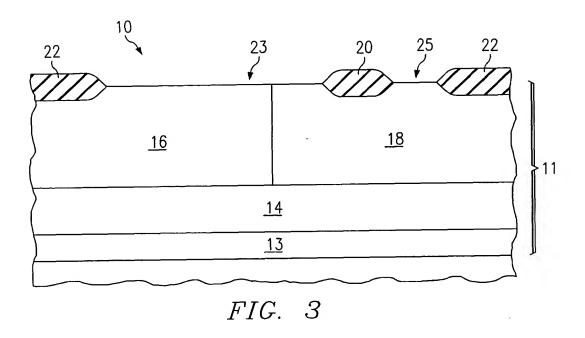


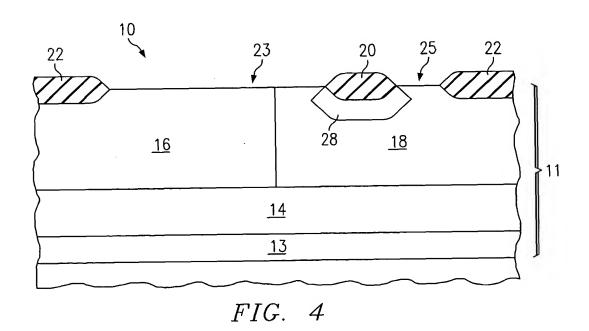


Structure

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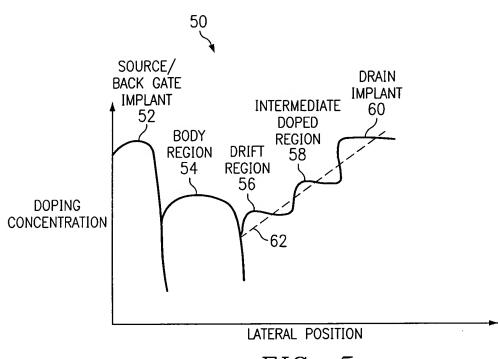


FIG. 5